

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuo MAEDA

Serial No.: 09/519,599

Filed: March 6, 2000

For: METHOD AND APPARATUS FOR FORMING AN INTERLAYER
INSULATING FILM AND SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)(3)

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that the examiner consider and cite of record the six references
listed on the attached, copies of which are submitted herewith.

Respectfully submitted,

George A. Loud
Reg. No. 25,814

Dated: August 24, 2001

LORUSSO & LOUD
3137 Mount Vernon Avenue
Alexandria, VA 22305

(703) 739-9393

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